Brief Biodata

Name: V. K. Jaiswal

| Designation: | Principal Scientist | |
|---------------------------|-----------------------------------|--|
| Sub. Div. No. and Name: | 1.04, Optical Radiation Metrology | |
| Division No. and Name: | 1, Physico-Mechanical Metrology | |
| Email: | jaiswalvk@nplindia.org | |
| Date of Joining CSIR-NPL: | February 01, 2008 | |
| Phone (office) | 45608228 | |
| Mobile (optional) | - | |

Research Area/ Interest:

Optical Radiation Metrology: Photometry and Radiometry, Applied and Fundamental Optics

Educational Qualifications:

(Please write latest qualification first)

| Degree | Subject | University/ Institute | Year |
|---------|----------------------------------|---------------------------------------|------|
| M. Tech | Applied Optics | Indian Institute of Technology, Delhi | 2002 |
| M. Sc. | Physics | University of Allahabad | 2000 |
| B. Sc. | Physics, Statistics, Mathematics | University of Allahabad | 1997 |

Academic / Research Experience:

| Grade / Post | Institute | Duration | | Research Field | |
|---------------------|---|----------|--------------|---|--|
| | | From | То | | |
| Principal Scientist | CSIR-National Physical Laboratory, New Delhi | 2016 | Till Date | Photometry and Radiometry, Applied and Fundamental Optics | |
| Senior Scientist | CSIR-National Physical Laboratory, New Delhi | 2013 | 2016 | -do- | |
| Scientist C | CSIR-National Physical Laboratory, New Delhi | 2008 | 2013 | -do- | |
| Scientist SC | Physical Research Laboratory, Ahmedabad (Dept. of Space, GoI) | 2002 | 2008 | Fundamental Optics: Laser Physics and Quantum Optics | |

No. of Publications: 19 publications in SCI Journals

| No. of Publications in SCI Journals | No. of Publications in non-SCI Journals | No. of Publications in Conference Proceedings | Contributions to Books | Total |
|---|--|--|---------------------------|-------|
| 19 | Nil | 69 | 12 | 100 |

Selected Publications:

- (i) Rajeev Dwivedi, et al, "Elliptically squeezed axicon phase for detecting topological charge of vortex beam", *Opt. Commun.*, **485**, 126710 (2021)
- (ii) S. Saha, et al, "Evolution of SI Base Unit Candela: Quantifying the Light Perception of Human Eye", *MAPAN J. of Met. Soc. of India*, **35(4)**, 563-573 (2020)
- (iii) V. K. Jaiswal, et al, "Producing optical vortices through forked holographic grating: study of polarization", *J. of Mod. Opt.*, **57**, 2031-2038 (2010)

Patents:

(i) UVC Disinfection Casket (Under process)(ii) UVC based air microbial disinfection unit (Under process)

Current Activities:

(Not more than 100 words)

Working in metrology of optical radiation, Applied and Fundamental Optics.

Apart from fundamental optics, photonics and Photometry and Radiometry, as a group head, Optical Radiation Metrology, the current emphasis of our group is in creating apex level testing and calibration facilities to render apex measurement traceability and pave the way in LED metrology as well, supporting Indian Industries for their endeavours in producing export quality products.

Honour(s)/Award(s)/ Fellowship(s):

GATE-2000 Fellowship JEST-2000 Fellowship

Contributions to AcSIR:

(1) Teaching the following AcSIR courses:

- (i) Quantum Optics and Advanced Solid State Optical devices (Pre-PhD students of the Laboratory)
- (ii) Optical Radiation Metrology to Students of PGD-PMQC (Precision Metrology and Quality Control)
- (2) Member of several academic evaluation and advisory committees

Membership of Professional Societies/ Institutions:

- (1) Sectional Committee, ETD 23 of Bureau of Indian Standards (BIS) on 'Lamps and Related Equipment'
- (2) Sectional Committee, ETD 49 of Bureau of Indian Standards (BIS) on 'Illumination Engineering and Luminaires'
- (3) Sectional Committee of Ophthalmic Instruments and Appliances (MHD 05) of Bureau of Indian Standards (BIS), New Delhi
- (4) Metrology Society of India (MSI), New Delhi

Any other Information:

(Not more than 100 words)